## OPERATION AND PERFORMANCE OF THE HIGH-INTENSITY PROTON INJECTOR OF LAMPF\*

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#### ABSTRACT

The recent operational experience with the LAMPF high-intensity proton injector is presented. Extensive beam measurements have been carried out on the ion beam extracted from the accelerating column and the results are compared with the behavior expected from a Pierce column. Improvements made in the ion source and other injector systems are presented; operation over a wider range of extracted currents without arc down is now possible. A major cause of arc down in the accelerating column was traced to occasional failure of the arc modulator turn-off circuit and has been eliminated. A procedure for enhancing the hydrogen pumping speed of the ion pumps is discussed.

### I. INTRODUCTION

The high-intensity proton injector for LAMPF has been in operation for over two years and has been used to supply 750-kV proton beams for the initial testing and preliminary operation of the LAMPF accelerator. Most of the operating problems previously reported<sup>1</sup> have been corrected, and the injector is now quite reliable at low-duty factor operation. During the initial 800-MeV turn on of LAMPF, this injector ran for 92 h with only one arc down. Work is still in progress to improve the arcdown rate at high-duty factor operation.

Difficulties experienced in optimizing the performance of the injector beam transport system led to a series of beam measurements at the exit of the accelerating column. The transverse emittance of extracted beam was measured for a wide range of ion source parameters and the properties of the beam entering the transport line were experimentally determined. Using these results, a new design for this transport system was calculated and subsequently implemented. II. COCKCROFT-WALTON HIGH-VOLTAGE GENERATOR

Modifications have been made to improve the performance of the Cockcroft-Walton (C-W) bouncer circuits. The loop gain available to drive the series FHT7 was increased in order to improve the dynamic response of this system. It was then necessary to introduce additional current feedback since the control loop was almost unstable. The initial voltage drop in the bouncer is now ~ 250 V for a 40-mA current pulse, and after the first 10 µsec the variation in voltage is about  $\pm$  75 V or  $\pm$  0.01% of the 750-kV operating voltage.

## III. DUOPLASMATRON ION SOURCE

During the past year the duoplasmatron ion source has been in operation for over 3000 h with the new design for the anode aperture plate shown in Fig. 1. The only component failure in this source during this time has been a filament which was severed after 2000 h of operation. Some erosion of the anode aperture was noted at this time; the aperture had increased from 0.025- to 0.031-in.diam

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and was slightly elliptical. During the first six months of operation with the new anode aperture, the proton fraction from the source slowly decreased from 82 to 70% but now appears to have stabilized.



Fig. 1. Anode aperture plate for the LAMPF duoplasmatron.

The source has been modified to provide hydrogen gas feed lines and pressure monitors through the side wall of the source into the space between the plasma anode aperture and the intermediate electrode. No change in operation of the source was noted, contrary to our expectations. The use of side feed lines does permit easier replacement of the filament and arc magnet coil.

Work has been recently carried out to measure the magnetic field in the expansion cup region of duoplasmatron in order to understand changes in beam size observed with arc magnet current. The magnetic field observed is shown in Fig. 2.

#### IV. COLUMN ARC-DOWN STUDIES

A major cause of column arc-down under lowpower operating conditions was traced to a malfunction of the modulator controlling the ion source. Turning on the beam after it had been off for more than 8 sec invariably caused an arc-down.

The problem was caused by the decay of a delay line voltage which occurred when the input signals to the modulator were turned off. This condition left insufficient voltage for the SCR to turn off the beam at the end of the beam gate pulse and resulted in a long pulse with beam current gradually decreasing to zero over 5000 µsec as the modulator



Fig. 2. Magnetic field measurements in the expansion cup of the LAMPF duoplasmatron. The variation of magnetic field along the duoplasmatron axis and the variation of the magnetic field with magnet current at a point 0.25 in. downstream from the Pierce anode are shown.

capacitor discharged. With the extractor voltage set for the design current level, the diminishing beam current would inevitably spray the electrodes. Apparently some delay mechanism is involved since the actual arc-down always occurred about 20 msec after the end of the long pulse. Installation of a simple charging circuit to keep sufficient voltage on the delay line at all times has eliminated this problem.

Observations to date show essentially all other arc-downs at 60 and 120 Hz are beam induced, occurring during the beam pulse or shortly thereafter. At very low repetition rates (e.g., 3.75 Hz) arcdowns are rare, and a much smaller percentage is beam-induced.

The accelerating column has remained on-line since it was installed. All repairs and modifications have been made on-line through the access ports in the transparent acrylic jacket.

## V. ACCELERATING COLUMN TESTS

An extensiv series of beam measurements has been carried out to determine the properties of the beam extracted from the accelerating column. These studies were motivated by the desire to do more realistic calculations for the injector beam transport system. A series of 104 high resolution, pepper-pot emittance photographs was taken with a titanium pepper-pot assembly shown in Fig. 3. The layout for these experiments is presented in Fig. 4 and a typical emittance pattern photograph is shown in Fig. 5.



Fig. 3. Pepper-pot emittance measuring device used in the accelerating column beam tests.



Fig. 4. Layout of the components employed in the accelerating column beam tests.

Electron neutralization effects were neglected because the pepper pot was biased to a sufficient voltage to prevent secondary electrons from escaping. Moreover, the gas pressure in the accelerating tube was sufficiently low (~  $1 \times 10^{-5}$ ) to preclude any



Fig. 5. Pepper-pot emittance pattern for a 50-mA extracted beam at 1.75 A magnet current.

significant neutralization from gas ionization. The data on these photographs were digitized and analyzed by a computer data reduction process. The envelope size and divergence of the exit beam were determined in each case and a graph showing these results is presented in Fig. 6; a tabulation of beam parameters is presented in Table I. When the accelerating column was operated at the emittance corrected Pierce current<sup>†</sup> (45.3 mA for a 70% proton



Fig. 6. Summary of pepper-pot data showing envelope size and divergence of the beams observed.

<sup>&</sup>lt;sup>T</sup>The emittance corrected Pierce current is discussed in another paper in these proceedings; D. W. Mueller, "RMS Emittance and the LASL LAMPF Beam."

TABLE	I
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Picture No.	Arc Magnet Current (A)	Extractor Voltage (V)	Electron Trap Voltage (kV)	Transformer Current (mA)	Chamber Pressure (µ)	Repetition Rate (Sec <sup>-1</sup> )	Pulse Width (µsec)
1A 2A 3A 4A 5A	1.75 1.75 1.75 2.37 1.75	25.8 25.8 27.0 25.8 25.8	-10 -10 -10 -10 -10	48 48 48 32	98 98 98 98 98	15 15 15 15 15	100 100 100 100 100
6A 7A 8A 9A 10A 1B 2B 3B 4B 5B 6B	1.75 1.75 1.75 1.75 1.75 1.75 1.75 1.75	25.8 25.8 25.8 25.8 25.8 25.8 25.8 25.8	-10 -10 -10 -10 -10 -10 -10 -10 -10	44 49 50 36 10 20 28 32 36 40	98 98 98 120 120 120 120 120 120	15 15 15 15 15 15 15 15 15 15	100 100 100 100 100 100 100 100
1 2 3 4 5 6 7 8 9	1.75 1.75 1.75 1.75 1.75 1.75 1.75 1.75	25.8 25.8 25.8 25.8 25.8 25.8 25.8 25.8	-10 -10 -10 -10 -10 -10 -10 -10 -10	10 20 28 32 36 40 44 48 48	120 120 120 120 120 120 120 120 120	15 15 15 15 15 15 15 15 15 15	100 100 100 100 100 100 100 100
10 11 12 13 14 15 16 17 18	1.75 1.75 1.75 1.75 1.75 1.75 1.75 2.50 2.6	27.0 27.0 27.0 27.0 27.0 27.0 27.0 25.8 25.8	-10 -10 -10 -10 -10 -10 -10 -10 -10	44 40 36 32 28 20 10 10 7	120 120 120 120 120 120 120 120 120	15 15 15 15 15 15 15 15 15 15	100 100
19 20 21 22 23 24 25 26 27	1.7 2.6 2.6 2.6 2.6 2.60 2.60 2.60 2.60	25.8 25.8 25.8 25.8 25.8 25.8 25.8 25.8	-10 -10 -10 -10 -10 -10 -10 -10 -10	10 10 28 32 36 40 44 48	120 120 120 120 120 120 120 120 120	15 15 15 15 15 15 15 15 15 15	100 100 100 100 100 100 100 100
28 29 30 31 32 33 34 35 36	2.54 2.54 2.54 2.54 2.54 2.54 2.54 2.54	27.0 27.0 27.0 27.0 27.0 27.0 27.0 27.0	-10 -10 -10 -10 -10 -10 -10 -10 -10	48 44 40 36 32 28 20 10 48	120 120 110 110 110 110 110 110 120	15 15 15 15 15 15 15 15 15	100 100 100 100 100 100 100 100
30 37 38 39 40 41 42 43	1.75 1.75 1.75 1.75 1.75 1.75 1.75 2.54	27.0 27.0 27.0 27.0 27.0 27.0 27.0 27.0	-10 -10 -10 -10 -10 -10 -10	48 48 48 48 48 48 48	120 120 120 130 130 140 110	15 15 15 15 15 15 15	100 100 100 100 100 100

# TABLE I (continued)

Picture <u>No.</u>	Arc Magnet Current (A)	Extractor Voltage (V)	Electron Trap Voltage (kV)	Transformer Current (mA)	Chamber Pressure (µ)	Repetition Rate (Sec <sup>-1</sup> )	Pulse Width (µsec)
հհ	1.75	25.8	-10	10	110	120	10
45	1.75	25.8	-10	20	110	120	10
46	1.75	25.8	-10	28	110	120	10
L7	1.75	25.8	-10	32	135	120	10
18	1.75	25.8	-10	36	135	120	10
49	1.75	25.8	-10	40	135	120	10
50	1.75	25.8	-10	44	135	120	10
51	1.75	25.8	-10	38	135	120	10
52	1.75	25.8	-10	51	135	120	10
53	1.75	25.8	-10	10	100	120	20
54	1.75	25.8	-10	20	100	120	10
55	1.75	25.8	-10	28	100	120	10
56	1.75	25.8	-10	32	100	120	10
57	1.75	25.8	-10	36	100	120	10
58	1.75	25.8	-10	40	105	120	10
59	1.75	25.8	-10	44	110	120	20
60	1.75	25.8	-10	48	140	120	20
61	1.75	25.8	-10	50	140	120	20
62	1.75	25.8	-10	10	170	15	100
63	1.75	25.8	-10	20	170	15	100
64	1.75	25.8	-10	28	170	15	100
65	1.75	25.8	-10	32	170	15	100
66	1.75	25.8	-10	36	170	15	100
67	1.75	25.8	-10	40	170	15	100
68	1.75	25.8	-10	44	170	15	100
69	1.75	25.8	-10	40 50 5	170	12	100
70	1.75	25.0	-10	50.5	10	15	100
71	1.75	25.0	- >	10	125	17	100
(2	1.17	27.0	- >	20	125	15	100
[3 7]	1.()	25.0	- 5	20	125	15	100
(4 75	1 75	25.8	- 5	36	125	15	100
76	1 75	25.8	- 5	70 70	125	15	100
70	1 75	25.8	- 5	40 hh	125	15	100
78	1.75	25.8	- 5	48	130	15	100
79	2.60	25.8	- 5	48	130	15	100
80	2.60	25.8	- 5	44	130	15	100
81	2.60	25.8	-10	44	130	15	100
82	2,60	25.8	- 5	30	130	15	100
83 84	1.75	25.8	-10	44	130	15	100
85	1.75	27.0	0	32	65	15	100
86	1.75	27.0	0	40	65	15	100
87	1.75	27.0	0	48	80		
88	1.75	27.0	-10	40	80	15	100

fraction), the observed beam size and envelope divergence at the pepper pot was 1.2-cm radium and 15.1 mrad respectively.

To allow comparison with previous estimates of the beam phase space, the data of Fig. 6 were transformed back to the center plane of the tenth electrode. This procedure allows beam transport calculations to be done from the exit of the column. The transformation was done with an azimuthally symmetric Kapchinskij-Vladimirskij envelope code. Consideration was taken of the higher charge density of the  $H_2^+$  ion species. The results obtained after this transformation for beams with various beam currents at the standard operating conditions are presented in Fig. 7. In particular, for the case where the accelerating column was operated at the emittance corrected Pierce current (45.3 mA), a beam size of 1.0-cm radius and an envelope divergence of 14.6 mrad was obtained at the exit of the accelerating column. For this beam size, the exit lens effect of the accelerating column will account for 11.0 mrad of envelope divergence. The remainder of the envelope divergence and the growth of the beam size in the accelerating tube itself is believed to be due to the details of the phase space distribution of the beam extracted from the plasma surface in the duoplasmatron.



Fig. 7. Pepper-pot data showing envelope size and divergence at the exit of the accelerating column for beams run at standard operating conditions.

#### VI. COLUMN OPERATION - OFF DESIGN CURRENTS

The Pierce electrodes in the accelerating tube (see Fig. 4) were initially designed to compensate for the space charge of a 50-mA proton beam. The voltage gradient of the tube was subsequently changed by the addition of an electron trap biased at -10 kV, changing the design current of the tube to 55.6 mA of protons. For a typical  $H^+/H_2^+/H_3^+$  species ratio of 70/25/5, the column current required to produce the same space charge loading is 51.8 mA. A further correction has been made to take into account the finite emittance of the beam extracted from the ion source; this correction consists in reducing the extractor voltage and the extracted current from the Pierce design value in order to obtain some focusing after the extractor. The basis of this correction was a theoretical estimate of the conditions required to keep the rms radius of the beam constant in the column. The emittance-corrected Pierce current (ECPC) is 45.3 mA which corresponds to an extractor voltage of 25.8 kV, assuming a beam emittance of 1.25  $\pi$ -cm mrad at 750 kV. These conditions are then the emittance-corrected design conditions for this accelerating column.

During the first 2 years of operation the current extracted from the accelerating column was often chosen at a value different from the design current while keeping the extractor voltage constant at the emittance-corrected design value (25.8 kV). At currents appreciably above and below the emittance corrected Pierce current (ECPC) the beam was scraped on the column electrodes and the x-ray background from the column increased as shown in Fig. 8. At current well below the ECPC, the tails (crossover satellite structures) of the beam are being scraped on the column electrodes while for current somewhat above ECPC, the space charge blowup of the beam is causing the main core of the beam to be scraped by the electrodes.

In order to achieve optimal operation of the accelerating column and to minimize aberrations in the beam, it is desirable to operate the duoplasmatron so that the ion beam is extracted from a nearly flat plasma surface. Thus, as the operating parameters of the ion source are varied to obtain other extracted currents than ECPC, the extractor voltage should be varied to keep the plasma surface flat.



Fig. 8. Measured x-ray radiation at the door of the C-W Faraday cage as a function of extracted current from the accelerating column. The extractor voltage is held constant at the value determined by the Child-Langmuir law for the design current (ECPC) of the accelerating column.

The required voltage variation is determined by the Child-Langmuir Law:

V = 6.959 x 
$$10^4 \left(\frac{I_p}{\pi R^2}\right)^{2/3} z^{4/3}$$
 volts

where R is the beam radius in cm, z is the distance along the column axis in cm. I is the equivalent proton current in amperes, given by:

$$I_{p} = I\alpha = I\left(\frac{H_{1}^{+}}{\sum_{i=1}^{3}H_{1}^{+}} + \frac{H_{2}^{+}\sqrt{2}}{\sum_{i=1}^{3}H_{1}^{+}} + \frac{H_{3}^{+}\sqrt{3}}{\sum_{i=1}^{3}H_{1}^{+}}\right)$$

where I is the measured current extracted and the fractions are the indicated species ratio.

Programming the extractor voltage in accordance with the extracted current in this manner keeps the plasma surface nearly flat and thus moves the ion optic lens from the plasma surface to the extractor region. As the extractor voltage is lowered, additional focusing then occurs at the extractor electrode. As a result, x-ray radiation has been almost eliminated at the lower currents (Fig. 9) and the onset of high radiation production has been extended to higher peak currents.



Fig. 9. Measured x-ray radiation at the door of the C-W Faraday cage as a function of extracted current from the accelerating column. For each extracted current, the extractor voltage was adjusted in accordance with the Child-Langmuir law. The extractor voltage is also plotted.

The shape of the x-ray radiation curve in the 20- to 50-mA range is significant. The measured radiation is linear with current and the extrapolated curve passes through the origin. This radiation is attributed to backstreaming electrons from ionization of the residual gases in the accelerating tube. This ionization, and hence the radiation, should be proportional to beam current and gas pressure. Any deviation of radiation from linearity would then indicate that the beam is being scraped by the electrodes. This hypothesis has been confirmed by measuring the current to the electrodes and changing the gas pressure in the column. It is important to note that this low radiation level would be completely masked if it were not for the electron trap which prevents backstreaming electrons from entering the accelerating tube.

The effectiveness of the electron trap is illustrated in Fig. 10 which shows the x-ray background as a function of electron trap voltage.

To test the concept of radiation resulting from residual gas ionization, the hydrogen pressure in the accelerating tube was reduced from 3.9 x  $10^{-5}$ to 1.5 x  $10^{-5}$  torr, resulting in a corresponding



Fig. 10. X-ray background radiation as a function of electron trap voltage.

decrease in radiation from 10 to 6 mR/h at the outside wall of the Faraday cage. Using the radiation yield as an indication of beam impingement on the electrodes, it must be concluded that no significant amount of current strikes the electrodes between 20 mA and the emittance-corrected Pierce current (45.3 mA). Since we have observed a direct relationship between radiation level and column arc downs, programming the extractor voltage will result in more reliable operation with fewer arc downs from being impingement on the electrodes.

## VII. ENHANCED HYDROGEN PUMPING

During the accelerating column beam tests, frequent opening of the vacuum system caused an appreciable time loss waiting for the hydrogen ion pump to achieve enhanced pumping. The problem may have been aggravated by having only one pump in service which was almost ready for replacement.

The loss in pumping speed after opening the system is due to nitrogen creating a surface barrier to the diffusion of molecular hydrogen into the titanium as discussed by Singleton.<sup>2,3</sup> When this surface barrier is present, only ionized hydrogen can be pumped. If the surface barrier is removed, both hydrogen ions and molecular hydrogen are pumped and the total pumping speed is about 2-1/2 times the ionic component alone. The ionic pumping speed of each of our hydrogen ion pumps is about 1200  $\ell$ /sec and if we remove the surface barrier on the titanium, we can increase this to 3000  $\ell$ /sec. With two pumps in parallel, the additional 3600  $\ell$ /sec available due to enhancement pumping is sufficient incentive to remove this impurity layer and prevent it from reforming during operation. It is essential that all leaks in the vacuum system be eliminated since this barrier on the titanium can be formed by as little as 3 x 10<sup>-8</sup> torr partial pressure of nitrogen.

This surface barrier can be removed by sputtering with hydrogen during normal operation but this takes 24 to 48 h. Argon is at least 100 times more efficient than hydrogen and has been used to enhance the pumping of hydrogen in sputter ion pumps.<sup>4</sup> After every pump down, we remove this impurity layer by introducing argon into the system at 2 x  $10^{-5}$ torr. A 20-min treatment with the pump operating is sufficient to enhance the pumping speed by a factor of 2-1/2. For the same chamber pressure of 80 mtorr of hydrogen, the vacuum system pressure dropped from 1.3 x  $10^{-5}$  to 5 x  $10^{-6}$  torr as a result of the argon sputtering. Another advantage of this enhanced mode of pumping is the substantial reserve pumping speed for hydrogen even when power is inadvertently removed from the pump. While the ionic pumping is then reduced to zero, the residual molecular hydrogen and other active gases will still be pumped by the clean titanium surfaces, which will keep the pressure relatively low for days in a clean, tight system.

#### VIII. BEAM TRANSPORT SYSTEM

A beam transport system is used to transport proton beams from the injector to the first tank of the linac and has been previously reported. Initial operation of this system met design goals but indicated that greater beam currents could be transported to the linac if beam loss at the prebuncher were reduced. As a result of the accelerating column tests, a new design for the transport system was calculated and additional quadrupole lenses were added. The details of the new transport design are discussed in another paper in these proceedings.<sup>†</sup>

Additional viewing screens have added to the beam line so that beam cross sections can now be observed at four points along this beam line. A photo-

<sup>&</sup>lt;sup>†</sup>R. R. Stevens, Jr., B. Goplen, J. Stovall, "Beam Transport Studies on the Proton Beam Line in the Injector Complex of LAMPF," Proc. this Conference.

graph of one of the viewing screen devices is shown in Fig. 11, and the beam cross sections now obtained along the beam line are shown in Fig. 12.

Work is now in progress to eliminate the halo structures present in these beams. Prototype beam scrapers have been installed and tested and high power units are now being built. The present scrapers remove ~ 6 mA of beam, primarily at the prebuncher, and result in a 28-mA beam at the linac entrance with an emittance of 1.2  $\pi$  cm-mrad at 750 keV. Most of the halo structure previously present at this point has now been eliminated. The installaof beam scrapers is expected to facilitate the tuning of the injector beam line as well as reducing beam loss in the linac.



Fig. 12. Beam cross sections observed along the proton beam transport line.



Fig. 11. Beam viewing screen device.

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